

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

In re Application of: Eric Bornstein
Application Serial No.: 10/649,910
Filing Date: 26 August 2003
Title: NEAR INFRARED MICROBIAL ELIMINATION LASER
SYSTEM
Examiner: Shay, David M.
Art Unit: 3735
Atty. Docket No.: 072287-0019
Confirmation No.: 5770

CERTIFICATE OF MAILING OR TRANSMISSION

I hereby certify that this correspondence is being deposited with the U.S. Postal Service as first class mail in an envelope addressed to: Mail Stop Amendment, Commissioner for Patents, P. O. Box 1450, Alexandria, VA 22313-1450, or facsimile transmitted (571-273-8300) to the USPTO, on the date indicated below.

Date: 15 August 2007


Erin Olson

Mail Stop Amendment
Commissioner for Patents
P.O. Box 1450
Alexandria, VA 22313-1450

AMENDMENT

This paper is in response to the Office Action dated 29 June 2007 for the above-identified application. The Applicant appreciated the thorough examination of the subject application and requests reconsideration and further examination based on the following:

- **Amendments to the Claims**, as listed in the listing of claims beginning on page 2 of this paper;
- **Amendments to the Drawings**, beginning on page 6 of this paper and including seven attached replacement sheets; and
- **Remarks**, beginning on page 7 of this paper.